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ABSTRACT

An interconnect for testing semiconductor components includes a substrate, and contacts on the substrate for making demporary electrical connections with bumped contacts on the components. Each contact includes a recess and a pattern of leads cantilevered over the recess configured to electrically\engage a bumped contact. The leads are adapted to move in a x-direction within the recess to accommodate variations in the height and planarity of the bumped In addition, the leads can include projections for penetrating the bumped contacts, a non-bonding outer layer for preventing bonding to the bumped contacts, and a curved shape which matches a topography of the bumped contacts. leads can be formed by forming a patterned metal layer on the substrate, by attaching a polymer substrate with the leads thereon to the substrate, or be etching the substrate to form conductive beams.